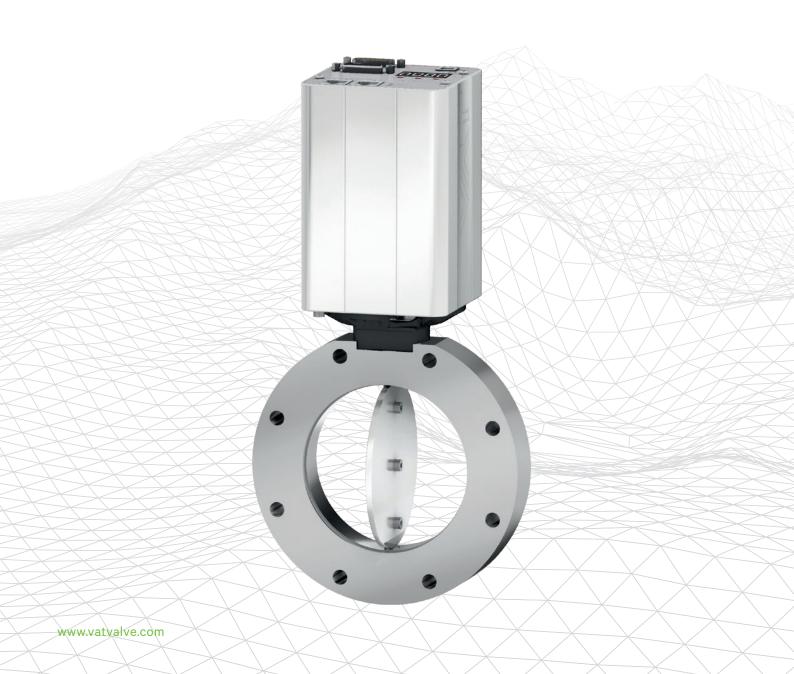


61.3 Butterfly Control Valve – Fast and Precise Downstream Pressure Control

VACUUM VALVE SOLUTIONS



61.3 Butterfly Control Valve – Outstanding Pressure Control Under All Conditions

The 61.3 Butterfly Control Valve provides outstanding pressure control performance. With its fast and precise acting motion controller (0.1s) it's the perfect solution for fine control in CVD and ALD processes. The plate acts as a throttling element and varies the conductance of the valve opening. The integrated pressure controller of the 61.3 calculates the required plate position to achieve the set pressure as fast as possible.

It is especially designed for harsh downstream processes with particle in the gas stream. The 61.3 stays fully operational despite high particle loads and debris accumulation by design.

Already installed in thousands of demanding applications under various process conditions, the 61.3 series has proven its outstanding reliability. With a robust design and direct mounting option, as well as reduced and easy maintenance, the 61.3 series convinces in all aspects.

Various design options in body material, surface treatment, elastomers, flange connections, special sizes as well as special control algorithms (adaptive, fix PI down-stream/ soft-pump) simplify the integration into various vacuum applications.





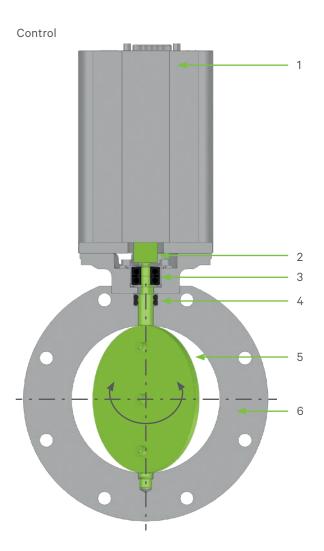
61.3 Butterfly Control Valve is available in aluminum or stainless steel, with standard flange connectors in ISO-KF and ISO-F. Customer-specific flanges can be integrated as well as special features like an integrated heater with insulation. Various FFKM/FKM elastomers are available on request (FKM is standard).

Features:

- Excellent pressure control
- Very fast operation
- On-board software for local operation
- Reliable operation in harsh processes conditions

Benefits:

- Better process controllability
- High uptime / unrestricted performance
- Low cost of operations



- 1 Controller
- 2 Coupling
- 3 Bearing
- 4 Double seal
- 5 Plate
- 6 Valve body



TECHNICAL DATA

Sizes			
Actuator			
Body material			
Standard flanges			
Leak rate: valve body ¹⁾	aluminum stainless steel		
Pressure range 1)			
Cycles until first service 2)	pressure control		
Temperature ²⁾	valve body		
Material	valve body / plate	aluminium stainless steel	
	shaft		
Seal	feedthrough		
Feedthrough			
Mounting position			
Max. differential pressure	on the plate	on the plate	
Conductance	molecular flow	molecular flow	
Minimum controllable conductance	molecular flow	molecular flow	
Typical closing or opening time "position only" version	aluminum, stainless s	aluminum, stainless steel	
Weight	aluminum valve stainless steel valve		

DN 25 - 320 mm (1" - 1	2")	
integrated controller control (foc)	with stepp	er motor, field oriented
aluminum or stainless	steel	
ISO-KF, ISO-F		
<1 × 10 ⁻⁹ mbar ls ⁻¹ <1 × 10 ⁻⁹ mbar ls ⁻¹		
<1 × 10 ⁻⁸ mbar to 1.2 ba	ar	
2 million		
≤ 150°C		
EN AW-6082 (3.2315) AISI 316L (1.4404 or 1 AISI 316L (1.4404 or 1	.4435)	
FKM (others on reque	est)	
rotating shaft, direct	driven	
any (shaft on pump si	ide recomn	nended)
DN 25		DN 320
1000 mbar		75 mbar
22 ls ⁻¹		27 000 ls ⁻¹
0.15 ls ⁻¹		6 ls ⁻¹
0.09 s		0.29 s
2.0 kg (4.40 lbs) 2.5 kg (5.5 lbs)		10.4 kg (23 lbs) 12.3 kg (27.1 lbs)

OPTIONS, CUSTOMIZED SOLUTIONS

VALVE
Reinforced version for harsh conditions (up to DN 160)
Customer specific flanges
Alternative body sizes
Alternative body materials
Alternative sealing materials

CONTROLLER

Calculates the required plate position to achieve the setpoint pressure Sensor Power Supply Option Power Failure Option

CONTROLLER-MODES

Adaptive, fix PI down-stream/soft-pump

CONTROLLER INTERFACES

Logic (analog/digital)	RS232 + AO	RS485 + AO
DeviceNet®	EtherCAT 3)	CC-Link
Profibus	Ethernet	Position Only

TEMPERATURE OPTIONS

200°C or 400°C version Heater with insulation jacket

- 3) CanOpen/EtherCAT CiA-402 Drive Profile (position, velocity, torque, homing...)

 ETG.5003 Semiconductor Device Profile

 ETG.5003.1 à Common Device Profile (CDP)

 ETG.5003.0002 à Firmware Update over EtherCAT

 ETG.5003.3030 à Process Control Valve Profile (profile under development; ETG release pending)

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²⁾ Maximum values depending on operating conditions and sealing materials.